

Application No. 10/576,486
Paper Dated: June 26, 2008
In Reply to USPTO Correspondence of March 26, 2008
Attorney Docket No. 0388-061179

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application No. : 10/576,486 Confirmation No. : 6114
Applicant : Chie Ishikawa et al.
Filed : December 21, 2006
Title : SURFACE DEFECT INSPECTING METHOD AND
DEVICE
Group Art Unit : 2877
Examiner : Iyabo S. Alli
Customer No. : 28289

Mail Stop Amendment
Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT

Sir:

In response to the Office Action dated March 26, 2008, Applicants submit the following amendments and remarks.

Amendments to the Claims which begin on page 2 of this paper.

Remarks which begin on page 7 of this paper.

I hereby certify that this correspondence is being electronically submitted to the United States Patent and Trademark Office on June 26, 2008.

06/26/2008
Date


Signature

Mary Ann Mulvihill
Typed Name of Person Signing Certificate